



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#7  
2-14-03

In re application of : Confirmation No. 8643  
Akira FUKUNAGA et al. : Docket No. 2001\_1767A  
Serial No. 09/994,755 : Group Art Unit 1723  
Filed November 28, 2001 : Examiner E. Therkorn

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TC 1700 MAIL ROOM

PLATING APPARATUS AND METHOD  
OF MANAGING PLATING LIQUID COMPOSITION

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

**RESPONSE TO RESTRICTION REQUIREMENT**

Assistant Commissioner for Patents,  
Washington, D.C.

Sir:

In response to the Restriction Requirement of February 3, 2003, Applicants hereby elect Group II, which is drawn to a method of managing a plating liquid composition and is embodied by claims 5 and 6.

Having made the required election, a full examination on the merits of the elected group is requested.

Respectfully submitted,

Akira FUKUNAGA et al.

By: Michael S. Huppert  
Michael S. Huppert  
Registration No. 40,268  
Attorney for Applicants

MSH/kjf  
Washington, D.C. 20006-1021  
Telephone (202) 721-8200  
Facsimile (202) 721-8250  
February 12, 2003